

Characterization and modeling of small-signal substrate resistance effect in RF CMOS (2002 Vol. I [MWSYM])

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A novel theory based on dual-feedback circuit methodology is proposed to explain the kink phenomenon of the scattering parameter S_{22} in deep submicrometer MOSFETs. Our results show that the output impedance of MOSFETs intrinsically shows a series RC circuit (for low substrate resistance) or a "shifted" series RC circuit (for very high substrate resistance) at low frequencies, and a parallel RC circuit at high frequencies. It is this inherent triple characteristic of the output impedance that causes the appearance of the double kinks phenomenon of S_{22} in a Smith chart. Our model can not only predict the behavior of S_{22} , but also calculate all S-parameters accurately. Experimental data of 0.25 μm -gate MOSFETs are used to verify our theory. Excellent agreement between theoretical values and experimental data was found.

 [Return to main document.](#)